



**ELECTRONIC COPY**

LG791616079  
Report verification at igi.org



April 15, 2026

IGI Report Number **LG791616079**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **10.02 X 9.83 X 7.15 MM**

**GRADING RESULTS**

Carat Weight **6.20 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

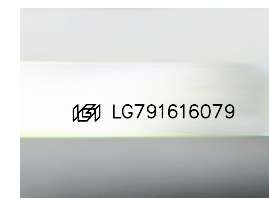
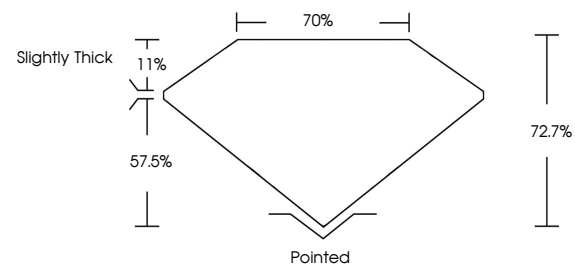
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG791616079**

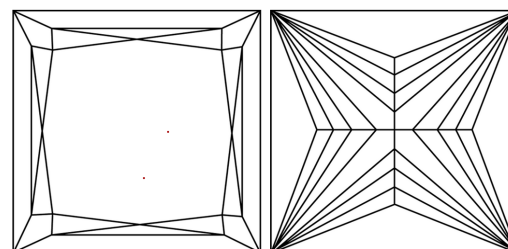
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

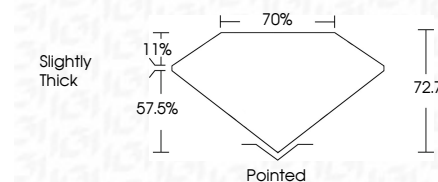
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



April 15, 2026  
IGI Report No **LG791616079**  
**PRINCESS CUT**  
**6.20 CARATS**  
E  
Carat Weight  
Color Grade **VVS 2**  
Clarity Grade **72.7%**  
Depth **70%**  
Table  
Girdle  
Slightly Thick  
Pointed  
Culet  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG791616079**  
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Type IIa